ELECTRIC BREAKDOWN IN SEMICONDUCTORS behind positively ionized atoms. This process is known as car-

which an electrically stressed semiconducting material is is called the depletion region [Fig. 2(a) and 2(b)]. transformed from its ''insulating'' or ''semiconducting'' state to Let a direct voltage be applied to this semiconductor, a ''conducting'' state. Breakdown voltage depends on a variety where the positive electrode is connected to the side that has of factors, including the material (for example, silicon or ger- the *p*-type material and the negative electrode is connected to manium), the temperature, the type of voltage applied (for the side that has the *n*-type material [Fig. 2(c)]. This is known example, direct, low-frequency alternating, high frequency al- as forward bias. The depletion region shrinks in width beternating, or impulse), lattice or crystal structure, level of im- cause the "*n*-type" electrons are getting a boost from the voltpurities, degree of doping, and degree of preexisting ioniza- age source to cross the barrier. However, if the direction of tion conditions. the voltage is reversed, the width of the depletion layer in-

article: $\ddot{ }$ away from the depletion region by the positive elec-

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tion wherein the first part of the crystal is grown with a dop- creases. Ultimately, the increased field is large enough to ing of trivalent material (group III elements in the periodic break a covalent bond, resulting in the release of electrons
table: boron, aluminum, gallium, indium, and thallium) re-
that constituted the bond. These electro table: boron, aluminum, gallium, indium, and thallium) results in forming a *p*-type material because the added impurity through the crystal because of the electric force applied on leaves certain of the covalent bonds missing one electron. them and in turn collide with other atoms and also break These trivalent atoms are called acceptor atoms. The second their covalent bonds. The process is called impact ionization. part of the crystal is grown with a doping of pentavalent ma- Thus ionization is cumulative and results in an avalanche. terial (group V elements in the periodic table: phosphorous, The magnitude of the voltage when this avalanche is created arsenic, antimony, and bismuth) results in forming an *n*-type and sustained to produce an avalanche current is called the material because the added impurity has an extra electron to reverse-breakdown voltage of the *p–n* junction diode. The recontribute to the crystal structure. These pentavalent atoms sulting current is called avalanche cur contribute to the crystal structure. These pentavalent atoms are called donor atoms. Figure 1 represents the crystal struc- breakdown is called avalanche breakdown. The resulting curture. The free electrons near the barrier in the *n*-type mate- rent may be large enough to destroy the *p–n* junction. By us-
rial diffuse over the *p–n* boundary to the other side, leaving ing a suitable series resistor rial diffuse over the $p-n$ boundary to the other side, leaving

rier depletion. In other words, there are no holes or electrons Breakdown voltage is defined as the potential difference at available in this region to carry current. This barrier region

Two types of breakdown phenomena are discussed in this creases because the electrons in the *n*-type material are being trode of the supply and the holes are attracted toward the 1. Avalanche breakdown cathode of the source. In this case the *p–n* junction is reverse-2. Zener breakdown biased [Fig. 2(d)].

As the voltage applied to the reverse-biased *p–n* junction For example, a silicon or germanium $p-n$ semiconductor junc- is increased, the electric field in the depletion region inthe current and thereby control the power dissipated. The *p–n* junction can actually be operated in its breakdown condition continuously.

> The *p*-type material and the *n*-type material are each lightly doped in a ''general-purpose diode.'' This type of diode is designed for operation in the forward-biased region and is supposed to carry the rated current continuously, without overheating. When a diode is reverse-biased, a small current is measured in the reverse direction called ''reverse saturation current.'' The breakdown voltage is relatively very high [Fig. 2(e)]. This current, called leakage current, is symbolically represented as I_0 .

ZENER BREAKDOWN AND ZENER DIODE

If the *p*-type material and the *n*-type material are each heavily doped, a zener diode is formed. The heavy doping increases the electric field in the depletion region and reduces the reverse-breakdown voltage. In this case, this reverse breakdown is called zener breakdown. In case of the diode *p–n* junction,

Average electric field strength in the depletion region

= applied reverse voltage/width of the depletion region

Therefore, it is possible to carefully control the breakdown voltage by adjusting the amount of doping through the width of the depletion region. At some level of the electric field **Figure 1.** Crystal structure of silicon with doped impurities. strength, the mechanisms of electric breakdown change from

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(**e**)

Figure 3. (a) An example of zener breakdown characteristics; (b) ideal characteristics of a zener diode.

avalanche multiplication to tunnel or zener breakdown. Zener breakdown is estimated to take place at approximately 300,000 V/cm. (As a comparison, the breakdown strength of air is 33,000 V/cm.)

Zener breakdown and avalanche breakdown may occur independently or simultaneously. Zener breakdown takes place typically at low values of reverse-bias voltages.

Figure 2. (a)–(d) Depletion region formation in a $p-n$ junction semi-
conductor; (e) forward characteristics and reverse breakdown charac-
shown in Figs. 3(a) and 3(b). The forward-bias characteristic teristics of a p –*n* junction diode. of the diode is not of particular interest in the case of zener. In the reverse, the zener maintains a voltage of V_Z regardless

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of the magnitude of the current in the reverse direction. Therefore, the principal application of the zener is for voltage regulation. With zeners, it is possible to maintain the output voltage (of a power supply, for example) constant, regardless of the changes in the load current. An example is shown in Fig. 4(a). This is a simplified version of a power supply regulator circuit. The input from a rectifier circuit has a dc voltage of 11 V but has a 1 V peak-to-peak ac component superimposed on it. A 10 V zener along with a current limiting protective resistor, connected as shown, eliminates the ac component and yields a pure dc voltage of 10 V [Figs. 4(b) and 4(c)]. A zener diode may require a minimum threshold current of 20 mA (for example) for it to operate satisfactorily, sustaining a zener breakdown. It may be capable of carrying a maximum current of I_{ZM} . The maximum current is obviously limited by the maximum power dissipation permitted by the zener. Ze-

Figure 5. (a) and (b), Symmetrical zener limiter circuit and characteristics.

ner diodes are sometimes called breakdown diodes or reference diodes.

When two zener diodes are connected in a back-to-back configuration, it is called a double-breakdown diode or a varistor diode. The symbolic representation and the characteristic curve are shown in Figs. 5(a) and 5(b).

BREAKDOWN IN JUNCTION TRANSISTORS

A bipolar junction transistor can be a *p–n–p* junction or an *n–p–n* junction device. A transistor connected as a commonemitter amplifier configuration is shown in Fig. 6(a). In this case, the base-emitter junction is forward-biased and the base-collector junction is reverse-biased. The forward-biased junction drops by approximately 0.6 V to 0.7 V for silicon and 0.3 V for germanium. However, there is a possibility of voltage breakdown at the base–collector junction because it is reverse-biased and there is a maximum permissible voltage that the junction can safely carry. Two types of breakdown are possible:

- 1. Avalanche breakdown
- 2. Punch-through

An example of collector current versus collector voltage characteristics for a transistor is shown in Fig. 6(b). For the specified base currents, the collector current increases slightly as **Figure 4.** (a) Power supply regulator circuit uses zener breakdown the collector-emitter voltage increases. When the voltage is to provide constant voltage to the load resistance; (b) voltage wave- high enough (approximately 50 V on the graph), however, an form of input signal; (c) voltage waveform of output signal. avalanche sets in, and the transistor breaks down. As seen in

Figure 6. (a) Common-emitter amplifier circuit shows that the base- **Unijunction Transistor** emitter junction is forward-biased, whereas the base-collector junction is reverse-biased and avalanche may set in; (b) collector charac-
terms in the unijunction transistor is also called a *double-based diode*.
It has two doned regions as shown in Fig. 8(a). The symbolic

the base current for a given transistor, in the common-emitter configuration.

Punch-through takes place because of changes in the width of the depletion region, known as the *early effect.* Again the area of interest is the base-collector junction because of its reverse-bias voltage. The width of this reverse-biased, junction-depletion region increases as the magnitude of the voltage applied across the collector and emitter increases. As a result, the "effective base width" decreases. This reduction in base width, called early effect, can result in:

- 1. Decreased chances for the recombination of electrons and holes because the effective base width is narrower
- 2. An increase in the concentration gradient of the minority carriers in the neutral base region **Figure 7.** *n*-Channel JFET biasing: common-source configuration.

3. The width of the neutral base between the emitter–base and collector–base junctions approaching zero or becoming almost equal to zero.

Combination of all three results in a base that is extremely thin compared with the emitter and the collector. This results in the passage of current from the emitter to the collector without any resistance in the base and is called punchthrough.

Punch-through takes place at a fixed voltage given by

$$
V_{\text{JUNCTION}} = [q(N_{\text{D}})W^2]/[2\epsilon_0 \epsilon_{\text{r}}]
$$

where

 $q =$ the charge on an electron = 1.602×10^{-19} Coulombs $N_{\rm D}$ = the concentration of donor ions in the semiconductor

- $W =$ the width of the base
- ϵ_0 = the dielectric constant of free space = 8.852 \times 10⁻¹² F/m
- ϵ_r = the relative permittivity of the semiconductor material

Breakdown in junction field-effect transistors (JFETs) is again due to the creation of an *avalanche.* An example of an *n*-channel JFET biasing and its characteristics is shown in Fig. 7. The JFET must be operated in the saturation region and below the breakdown voltage specified by the manufacturer. Sometimes this may be as high as 120 V.

BREAKDOWN DEVICES

The phenomenon of breakdown has been utilized to develop several semiconductor devices, such as the unijunction transistor (UJT), the Schottky diode (the four-layer diode), the silicon-controlled rectifier (SCR), the directional diode thyrister (diac), and the bidirectional triode thyrister (triac).

teristics for a common-emitter amplifiers characteristics show that It has two doped regions, as shown in Fig. 8(a). The symbolic
an avalanche sets in at approximately 50 V resulting in huge cur-
rents.
transistors connect resistors R_1 and R_2 . It has three leads, identified as emitter, Base 1, and Base 2 (instead of emitter, base and collector). Fig. 6(b), avalanche breakdown voltages vary depending on

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the holding current. This holding current is also called the voltage V_{B2} . This voltage charges the capacitor via the resis-

The ratio $(R_1)/(R_1 + R_2)$ is called the intrinsic standoff ratio valley current. A typical characteristic of a unijunction tranand is denoted by the Greek letter η . Its value is approxi- sistor is shown in Fig. 8(d). One of the most common uses of mately in the range between 0.5 and 0.8. The transistor is off this type of breakdown device is in the "relaxation oscillator" as long as the emitter voltage is less than the standoff volt- circuit. Figure 8(e) shows a simple circuit that uses a resisage. Once the emitter voltage exceeds the standoff voltage, tance and a capacitance connected to the UJT to perform as the unijunction transistor fires, the transistor is turned on, a relaxation oscillator. A sawtooth waveform can be generated and remains on as long as the emitter current is greater than using this circuit. Base 1 is grounded, and Base 2 receives a

Figure 8. (a) Unijunction transistor constructional features (formerly known as duo-base diode); (b) UJT symbol; (c) UJT can be viewed as two transistors connected as shown above and η = $[(R_1)/(R_1 + R_2)]$; (d) unijunction transistor characteristics showing the negative resistance region; (e) UJT relaxation oscillator circuit; (f) sawtooth waveform generation using a UJT relaxation oscillator circuit. Discharge is fast and rapid because of breakdown phenomenon.

diode; (c) Schottky diode symbol; (d) characteristics of the Schottky Hill, 1979.
diode show that an avalanche sets in to break down the reverse-
 $\frac{15}{15}$ J Millmar diode show that an avalanche sets in to break down the reverse-
biased $n-p$ junction at V_{BR} (called the forward switching voltage, also V_{BR} Millman and A. Grabel, Microelectronics, 2nd ed., New York:
represented as

tance *R*. Once the capacitor voltage reaches the standoff volt- MYSORE NARAYANAN age of the UJT, the UJT fires and discharges the capacitor Miami University because the resistance between the emitter and the grounded Base 1 is very small. This causes a collapse in the capacitor voltage. Therefore the current ceases to exist, and the UJT is **ELECTRIC CIRCUITS, INTERVAL ANALYSIS FOR.** returned to its open state because there is no current to sus-
tain the UJT in the fired state. The cycle repeats, resulting in See INTERVAL ANALYSIS FOR CIRCUITS. tain the UJT in the fired state. The cycle repeats, resulting in the sawtooth waveform shown in Fig. 8(f). **ELECTRIC CIRCUITS, SENSITIVITY.** See SENSITIVITY

A four-layer silicon device with a $p-n-p-n$ junction is called SUREMENT.
a Schottky diode. A slight variation of this device is also **ELECTRIC CONDUCTORS.** See CONDUCTORS, ELECTRIC. a Schottky diode. A slight variation of this device is also called the silicon unilateral switch. In this case there are three junctions, identified as 1, 2, and 3 in the diagram shown in Fig. 9(a). Figure 9(b) shows the characteristics of the Schottky diode. When the device is connected as shown in the sketch, junctions 1 and 3 are forward-biased, whereas junction 2 is reverse-biased. When the voltage increases, the forward current increases only very slightly, as shown in Fig. $9(c)$. At V_{BR} an avalanche breakdown takes place at junction 2, and this permits the current flow to increase, as shown in Fig. 9(d). Only a few volts are dropped across the conducting diode, as shown in the diagram. The minimum current re-

quired is called the *holding current* represented by $I_{\rm H}$. Schottky diodes switch on within a microsecond and are very useful in triggering various electronic circuits.

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- ANALYSIS.
- **Schottky Diode ELECTRIC COMPONENTS.** See CAPACITANCE MEA-
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